## Notice of References Cited Application/Control No. 10/644,838 CHEN, CHIH-JU Examiner Art Unit Alix Elizabeth Echelmeyer Applicant(s)/Patent Under Reexamination CHEN, CHIH-JU Page 1 of 1

## **U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	Α	US-2004/0115519	06-2004	Lee, Sung Hun	429/061
	В	US-			
	С	US-			
	D	US-			·
	E	US-			
	F	US-			
	G	US-			
	Н	US-			
	L	US-			
	J	US-			
	К	US-			
	L	US-			
	М	US-			

## FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	0					-
	Р					
	Q					
	R					
	S	·				
	Т					

## **NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
į	U	
	<b>V</b>	
	w	
	x	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.